

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Patricia B. SMITH et al. Confirmation No.: 3087
Application Number : 10/647,985
Filed : August 26, 2003
Title : POST-ETCH CLEAN PROCESS FOR POROUS LOW
DIELECTRIC CONSTANT MATERIALS
TC/Art Unit : 1792
Examiner: : Eric Wayne Golightly

Docket No. : TI-33260 (0025.0184)
Customer No. : **23494**

MAIL STOP AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

REPLY TO OFFICE ACTION UNDER 37 CFR §1.111

Please enter the following in response to the Office Action mailed

August 28, 2008:

A listing the Claims is reflected in the listing of claims in this paper starting on
page 2.

Remarks/Arguments follow the amendment sections of this paper starting on
page 7.